Docket No.

249687US2/hd

IN THE VILLED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

Masakiyo MATSUMURA, et al.

SERIAL NO:

10/790,828

GAU:

FILED:

March 3, 2004

EXAMINER:

FOR:

CRYSTALLIZATION APPARATUS, CRYSTALLIZATION METHOD, PHASE MODULATION ELEMENT,

DEVICE AND DISPLAY APPARATUS

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Applicant(s) wish to disclose the following information.

REFERENCES

- The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.
- A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- □ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

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STATEMENT OF RELEVANCY

Reference AM (JP 2000-306859) on Form PTO-1449 is discussed in the specification.

Reference AQ on Form PTO-1449:

Please see Fig. 3 and its description.

Reference AR on Form PTO-1449:

Please see Fig. 2 and its description.

Reference AS on Form PTO-1449:

Please see Fig. 2 and its description.

Reference AT on Form PTO-1449:

The ninth slide.

Reference AU on Form PTO-1449 is discussed in the specification.

Reference AV on Form PTO-1449 is discussed in the specification.

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